

Notice of References Cited	Application/Control No. 10/588,291	Applicant(s)/Patent Under Reexamination LEUNG KI, YIT-SHUN	
	Examiner Patricia A. George	Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0022395	01-2003	Olds, Keith A.	438/3
*	B	US-5,694,229	12-1997	Drinkwater et al.	359/2
*	C	US-4,765,865	08-1988	Gealer et al.	438/705
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Leech; Fabrication of hologram coins using electron beam lithography; Microelectronic Engineering, Volume 71, Issue 2, February 2004, Pages 171-176; Available online 20 November 2003. □□
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.